



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hua Ji
Assignee: Mosel Vitelic, Inc.
Title: HDP CVD Process For Void-Free Gap Fill Of A High Aspect Ratio Trench
Serial No.: 10/080,468
Examiner: Anh D. Mai
Docket No.: M-12589US

Filing Date: February 22, 2002
Group Art Unit: 2814

Irvine, California
September 29, 2003

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
OCT 14 2003
TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated May 27, 2003, Applicant submits the following amendments and remarks. A one-month extension of time, extending the period for response to September 29, 2003, is requested in an accompanying petition.